

RCE/2881  
JAW**REQUEST FOR CONTINUED EXAMINATION  
UNDER 37 CFR 1.114**

Applicant(s) : Shin-ichi Hashimoto et al.  
App. No. : 10/672,469  
Filed : September 26, 2003  
For : ELECTRON BEAM EXPOSURE APPARATUS, DEFLECTION APPARATUS,  
AND ELECTRON BEAM EXPOSURE METHOD  
Examiner : Anthony G. Quash  
Art Unit : 2881

**Commissioner for Patents  
Alexandria, VA 22313-1450**

This is a request for continued examination under 37 CFR 1.114 in the above-identified utility patent application.

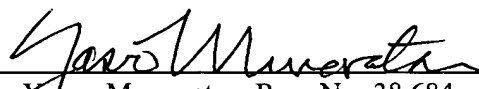
Enclosed:

- (X) An amendment in twelve (12) pages in response to the office action dated October 5, 2004 which is a bona fide attempt to advance the application.
- (X) A check in the amount of \$878.00 for RCE fee and one (1) excess independent claim fee (cause by the amendment in the claims concurrently submitted herewith) is enclosed.
- (X) Return prepaid postcard.

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

November 22, 2004

(Date)

  
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01 FC:1801  
02 FC:1201

790.00 OP  
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